



03-18-05

IFW #

Attorney's Docket No: 013921-000025

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Linthicum et al.)	
)	
Serial No.: 10/633,952)	Confirmation No.: 5174
)	
Filed: August 4, 2003)	
)	
Group Art Unit: 2812)	
Examiner: Mulpuri)	
)	
Title: Methods of Fabricating Gallium Nitride)	
Microelectronic Layers on Silicon Layers)	
and Gallium Nitride Microelectronic)	
Structures Formed Thereby)	

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.111

Sir:

This paper is being filed in response to the Office Action mailed November 17, 2004, having a reply due date of February 17, 2005. The Applicants hereby petition the Commissioner for Patents to extend the time for response by one (1) month to at least March 17, 2005. The appropriate fee for a Petition for Extension of Time is enclosed. Reconsideration of the application is respectfully requested in light of this response.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims begin on page 3 of this paper.

Remarks/Arguments begin on page 6 of this paper.